



Attorney Docket No. 069974-0143

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Keiichiro KATA et al.

Title: PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICE
AND SEMICONDUCTOR WAFER

Application No.: 10/645,782

Filing Date: 8/22/2003

Examiner: Mark Prenty

Art Unit: 2822

AMENDMENT AND REPLY UNDER 37 C.F.R. 1.173

Mail Stop Amendment

Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This amendment and reply is being filed in response to an Office Action dated January 19, 2006, for the above-identified application.

A petition and fee for a one-month extension of time is being submitted concurrently herewith.

Amendments to the Claims begin on page 2 of this document.

Remarks/Arguments begin on page 7 of this document.

Please amend the application as follows:

05/01/2006 JADDO1 00000021 10645782

01 FC:1201
02 FC:1251

400.00 OP
120.00 OP